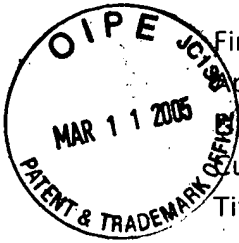


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



First Named Inventor: Baining Guo

Attorney Docket No.: 177794.1

Application No.: 09/928,257

Group Art Unit: 2671

Filed: 8/10/2001

Examiner: Kimbinh T. Nguyen

Customer No.: 22971

Confirmation Number: 5744

Title: MACROSTRUCTURE MODELING WITH MICROSTRUCTURE REFLECTANCE SLICES

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria VA 22313-1450

STATEMENT FILED PURSUANT TO
THE DUTY OF DISCLOSURE UNDER 37 C.F.R. §§ 1.56, 1.97 AND 1.98

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. §§ 1.56, 1.97 and 1.98, the

Applicant requests consideration of this Information Disclosure Statement.

Compliance with 37 C.F.R. § 1.97

This Information Disclosure Statement has been filed before the mailing date of a first Office Action after the filing of a request for continued examination under 37 C.F.R. 1.114.

No fee or certification is required.

Remarks

The Applicant hereby makes of record in the above-identified application the information listed on the attached forms PTO/SB/08A and 08B. The order of presentation of the references should not be construed as an indication of the importance of the references. Documents cited on the attached forms PTO/SB/08A and 08B are enclosed unless otherwise indicated. It is respectfully requested that:

1. The Examiner consider completely the cited information, along with any other information, in reaching a determination concerning the patentability of the present claims;
2. The enclosed form PTO/SB/08A be signed by the Examiner to evidence that the cited information has been fully considered by the Patent and Trademark Office during the examination of this application;
3. The citations for the information be printed on any patent which issues from this application.

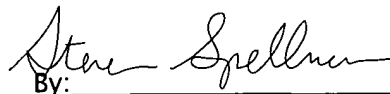
By submitting this Information Disclosure Statement, the Applicant makes no representation that a search has been performed, of the extent of any search performed, or that more relevant information does not exist.

By submitting this Information Disclosure Statement, the Applicant makes no representation that the information cited in the Statement is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

By submitting this Information Disclosure Statement, the Applicant makes no representation that the information cited in the Statement is, or is considered to be, in fact, prior art as defined by 35 U.S.C. § 102.

Notwithstanding any statement by the Applicant, the Applicant urges the Examiner to form his own conclusion regarding the relevance of the cited information. An early and favorable action is hereby requested.

Respectfully submitted,
MICROSOFT CORPORATION


By: _____

Date: 3-11-2005

Steven J. Spellman, Reg. No. 45,124
Microsoft Corporation Redmond,
Washington
Telephone (425) 707-3591

EXPRESS MAIL CERTIFICATION UNDER 37 C.F.R. § 1.10

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I hereby certify that this correspondence is being deposited with the United States Postal Service (USPS) as correspondence to be delivered by the "Express Mail Post Office to Addressee" service of the USPS on the date indicated below with sufficient postage in an envelope bearing the above-noted Express Mail mailing label number and addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

03-11-2005

Date

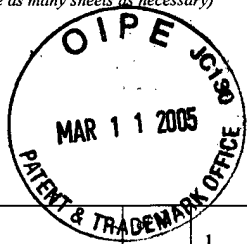


Signature

Rimma N. Oks

Type or Print Name

Substitute for form 1449/PTO		Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Application Number	09/928,257	
		Filing Date	08/10/2001	
		First Named Inventor	Baining Guo	
		Art Unit	2671	
		Examiner Name	Kimbinh T. Nguyen	
Sheet	1	1	Attorney Docket Number	177794.01



NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	1	YING-QING XU, YANYUN CHEN, STEPHEN LIN, HUA ZHONG, ENHUA WU, BAINING GUO, HEUNG-YEUNG SHUM, Photorealistic Rendering of Knitwear Using The Lumislice, ACM SIGGRAPH 2001, August 12-17 2001, pages 391-398, Los Angeles California.	<input type="checkbox"/>
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Examiner Signature		Date Considered	
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional) ² Applicant is to place a check mark here if English language Translation is attached.